

Docket No.: 60188-432



2812

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

:

Yoshiaki HASEGAWA, et al.

:

Serial No.: 09/993,771

:

Group Art Unit: 2812

Filed: November 27, 2001

:

Examiner: SAVITRI MULPUR

For: METHOD FOR MANUFACTURING SEMICONDUCTOR AND METHOD FOR  
MANUFACTURING SEMICONDUCTOR DEVICE

TECHNOLOGY CENTER 2800  
JUL 25 2003

RECEIVED

Mail Stop Restriction Requirement  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Noting the Office Action of June 25, 2003 wherein restriction has been required,  
Applicant(s) hereby elect Species 1 as identified in the Office Action, and identify claim 4 as  
reading thereon, for prosecution in the above-identified application.

To the extent necessary, a petition for an extension of time under 37 C.F.R. 1.136 is hereby  
made. Please charge any shortage in fees due in connection with the filing of this paper, including  
extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit  
account.

Respectfully submitted,

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Date: July 24, 2003